



AF
IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJITA, Kenichi, et al.**

Group Art Unit: **1714**

Serial No.: **10/622,513**

Examiner: **Vickey M. Ronesi**

Filed: **July 21, 2003**

P.T.O. Confirmation No.: 3785

**FOR: MASTER BATCH CONTAINING HEAT RADIATION SHIELDING COMPONENT,
AND HEAT RADIATION SHIELDING TRANSPARENT RESIN FORM AND HEAT
RADIATION SHIELDING TRANSPARENT LAMINATE FOR WHICH THE
MASTER BATCH HAS BEEN USED**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1714

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

August 31, 2005

In response to the final Office Action dated **June 3, 2005**, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.